

DOCKET NO: 260055US26SP PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :

TAKEHIRO UEDA, ET AL.

: EXAMINER: DAHIMENE, M.

SERIAL NO: 10/509,338 :

FILED: OCTOBER 8, 2004

: GROUP ART UNIT: 1765

FOR: METHOD FOR SUPPRESSING  
CHARGING OF COMPONENT IN  
VACUUM PROCESSING CHAMBER OF  
PLASMA PROCESSOR AND PLASMA  
PROCESSOR

*Do Not Enter*  
*1/9/08*  
*[Signature]*

AMENDMENT UNDER 37 C.F.R. § 1.116

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

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*now*  
*RCB/2.7.8*

In response to the Office Action dated September 7, 2007, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.